



IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

Applicant : Shinji Maekawa
Serial No. : 09/724,403
Filed : November 27, 2000
Title : METHOD OF MANUFACTURING A SEMICONDUCTOR DEVICE WITH
TENSILE STRESS (AS AMENDED)

Art Unit : 2813
Examiner : Laura Schillinger
Confirmation No.: 7575

Mail Stop Amendment

Commissioner for Patents
P.O. Box 1450
Alexandria, VA 22313-1450

RESPONSE TO RESTRICTION REQUIREMENT

Responsive to the action mailed November 30, 2005, applicant elects the invention of Species 5 drawn to the embodiment of Claims 61, 65-66 and 71 pertaining to a method including removing a tensile stressed material and forming a gate. The election is made without traverse.

Please apply any charges or credits to Deposit Account No. 06-1050.

Respectfully submitted,

Date: _____

12/27/05

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